

312-102



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Docket No. 0756-958

32/H
9-4-96
C. Brown

CERTIFICATE OF MAILING

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Deborah J. Tomme
Deborah T. Tomme

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | |
|------------------------------|------------------|
| In re PATENT application of: |) |
| Shunpei YAMAZAKI et al. |) |
| Serial No. 08/183,800 |) Examiner Saad |
| Filed: January 21, 1994 |) Art Unit: 2508 |
| For: SEMICONDUCTOR MATERIAL |) |
| AND METHOD FOR FORMING |) |
| THE SAME AND THIN FILM |) |
| TRANSISTOR |) August 5, 1996 |

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AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action mailed March 5, 1996, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 23-35 as follows:

23. (Three Times Amended) A thin film transistor comprising:

[an intrinsic channel] a semiconductor layer having an intrinsic
or substantially intrinsic channel region;

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